

Doc. No.: 2223007

Issue date: September 1, 2023

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Notification of Product/Process Change

This is an announcement of change(s) to the process of the products currently supplied by ROHM Co., Ltd.

We request your acknowledgement of the receipt of this notification within the given period.

Please provide your your reply by March 31, 2024

Title of change	SiC 3G MOSFET TO-263-7L package: 6inch Wafer introduction and Wafer factory (to Miyazaki) change			
	Manufacturer part number		Customer part number	
Affected product(s)	SCT3 W7TL			
Detailed description of change	Before		After	
	SiC wafer diameter: 4inch Wafer FAB: ROHM APOLLO Co., Ltd. Chikugo plant		SiC wafer diameter: 6inch Wafer FAB: LAPIS Semiconductor Co., Ltd. Miyazaki plant	
Reason for change	- To increase production output by enhancing productivity and efficiency - End of production of 4-inch SiC wafers due to the transition to 6inch SiC wafers			
Anticipated impact on quality	There is no difference in reliability and electrical characteristics.			
Identification of change	Traceable by Lot code			
Planned first ship date : April 1, 2024 Sample ava		nilable schedule :	September 1, 2023	
Comments				
Reply date				
		керіу	uate	
Customer reply	1. Approved. 2. Accepted with conditions.			
Condition for approval / reason for rejection				
Comments				
Customer company name				
Customer signature Depo		Departm	ment	
Customer signature Do		Departm	ment	